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OSTROLEN FABER, GERB & SOFFEN, LLP

Attorneys at Law
1180 Avenue of the Americas
New York, New York 10036-8403

(212) 382-0700

Telex
23 6925

Facsimile
(212) 382-0888

Cable
Ostrofaber NewYork

Express Mail #EL613112157US

Asst. Commissioner for Patents
Washington, DC 20231

OFGS File No. : P/2292-43
Inventor : Ki Young OH et al
Title : APPARATUS AND METHOD FOR FORMING ULTRA-THIN FILM
OF SEMICONDUCTOR DEVICE
Assignee : Jusung Engineering Co., Ltd.

Enclosed herewith please find the following documents in the above-identified application for United States Letters Patent:

Print EFS Data Sheet
 22 Pages of Specification including Abstract and Claims
 11 Numbered Claims Calculated as 11 Claims for Fee Purposes
 4 Sheets of Drawing Containing Figures 1 to 6. (Formal)
 X Declaration and Power of Attorney
 X Priority is Claimed under 35 U.S.C. §119:
Convention Date April 18, 2000 for Korea Apnl. S.N. 20239/2000
 X Certified Priority Application
 X Small Entity Status is claimed.
 X Assignment
 X Return-Addressed Post Card
OFGS Check No. 4227, which includes the fee of \$395.00, calculated as follows:
Basic Filing Fee: \$ 710.00
Additional Filing Fees:
 Total Number of Claims in Excess of 20, times \$18:
 Number of Independent Claims in Excess of 3, times \$80: . . .
 One or More Multiple Dependent Claims: Total \$270.
Total Filing Fees or
Total Filing Fee Reduced 50% for Small Entity: 355.00
Assignment Recording Fee: \$40 40.00
TOTAL Filing Fee and Assignment Recording Fee: \$ 395.00

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed, or if any additional fee during the prosecution of this case is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

EXPRESS MAIL CERTIFICATE

Respectfully submitted,

Max Moskowitz

Registration No.: 30,576
OSTROLEN, FABER, GERB & SOFFEN, LLP
1180 Avenue of the Americas
New York, New York 10036-8403
Telephone: (212) 382-0700

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail Post Office to Addressee (mail label #EL613112157US) in an envelope addressed to: Asst. Commissioner for Patents, Washington, D.C. 20231, on April 16, 2001:

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Dorothy Jenkins
Signature
April 16, 2001

Date of Signature

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INVENTOR INFORMATION

Inventor One Given Name:: Ki Young
Family Name:: Oh
Postal Address Line One:: Hanjin Apt. 808-404, Jungja-Dong
Postal Address Line Two:: Boondang-Ku, Sungnam
City:: Kyunggi-Do
Country:: Korea
City of Residence:: Sungnam
Citizenship Country:: Republic of Korea
Inventor Two Given Name:: Yong Ku
Family Name:: Baek
Postal Address Line One:: 202-25, Jeungsan-Dong, Eunpyung-Ku
City:: Seoul
Country:: Korea
Citizenship Country:: Republic of Korea

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 000002352
Electronic Mail One:: email@ostrolenk.com

APPLICATION INFORMATION

Title Line One:: Apparatus And Method For Forming Ultra-T
Title Line Two:: hin Film Of Semiconductor Device
Total Drawing Sheets:: 4
Formal Drawings?:: Yes
Application Type:: Utility
Docket Number:: P/2292-43
Secrecy Order in Parent Appl.?:: No

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 20239/2000
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Priority Claimed:: Yes

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